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Atty. Dkt. No. 069974-0143

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Keiichiro KATA et al.

Title:

PROCESS FOR

**MANUFACTURING** 

SEMICONDUCTOR DEVICE AND SEMICONDUCTOR WAFER

Appl. No.:

Application for Reissue of US Patent No. 5,844,304, granted

December 1, 1998

Examiner:

**TBD** 

Art Unit:

**TBD** 

## TRANSMITTAL OF FORMAL DRAWINGS

Commissioner for Patents PO Box 1450 Alexandria, Virginia 22313-1450

ATTENTION: DRAWING REVIEW BRANCH

Sir:

Transmitted herewith are the formal drawings (4 sheets, Figures 1A-1C, 2A-2G, 3A-3G, 4A-4C) for the above-identified application. The Official Draftsperson is respectfully requested to approve these drawings for entry into the application.

Respectfully submitted,

Date 8/20/0

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